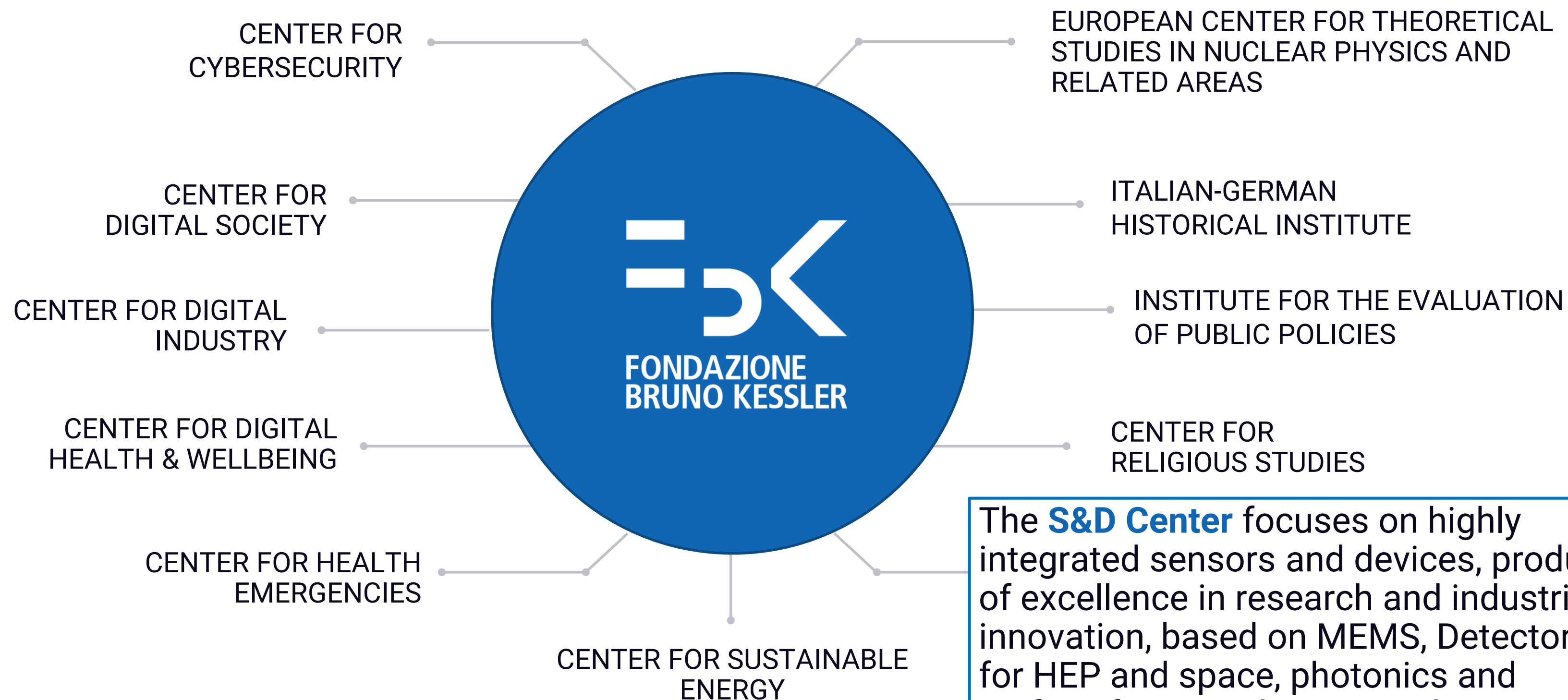


FBK

Research Centers (2021)



The **S&D Center** focuses on highly integrated sensors and devices, products of excellence in research and industrial innovation, based on MEMS, Detectors for HEP and space, photonics and surface functionalization techniques and interfaces

Microfabrication Area

Clean Room Detectors

700 m²; Class 10/100 6 inch pilot line: Ion Implantation, Oxidation, Diffusion, RIE, Deep RIE (silicon and oxide), Lithography (stepper and mask aligner and EBL), metal sputtering

Clean Room MEMS

500 m² Class 100/1000 diffusion, lithography (mask aligner), wafer bonding, electroplating, Si bulk micromachining, metal evaporation, RIE, mechanical and optical profilometry

Testing Area

300 m² manual parametric testing, automatic parametric/functional testing, optical testing (spectral responsivity, quantum efficiency)

Integration Area

100 m² clean room Class 1000 Microassembly station; screen printing, bonding (ball & wedge bonder), Shear-Pull Tester, reflow oven, CNC micro-mill

In progress: 3D Integration Area

TSV, thinning, trench filling



Custom Radiation Detectors

COMPETENCE

Design, production and packaging of innovative Radiation Sensors devices based on silicon compatible technology

- Single-photon detectors (full-custom and standard CMOS tech.)
- Silicon Drift Detectors
- Silicon Strip & pixel , single or double sided
- Low Gain Avalanche Diode
- Si -3D detector

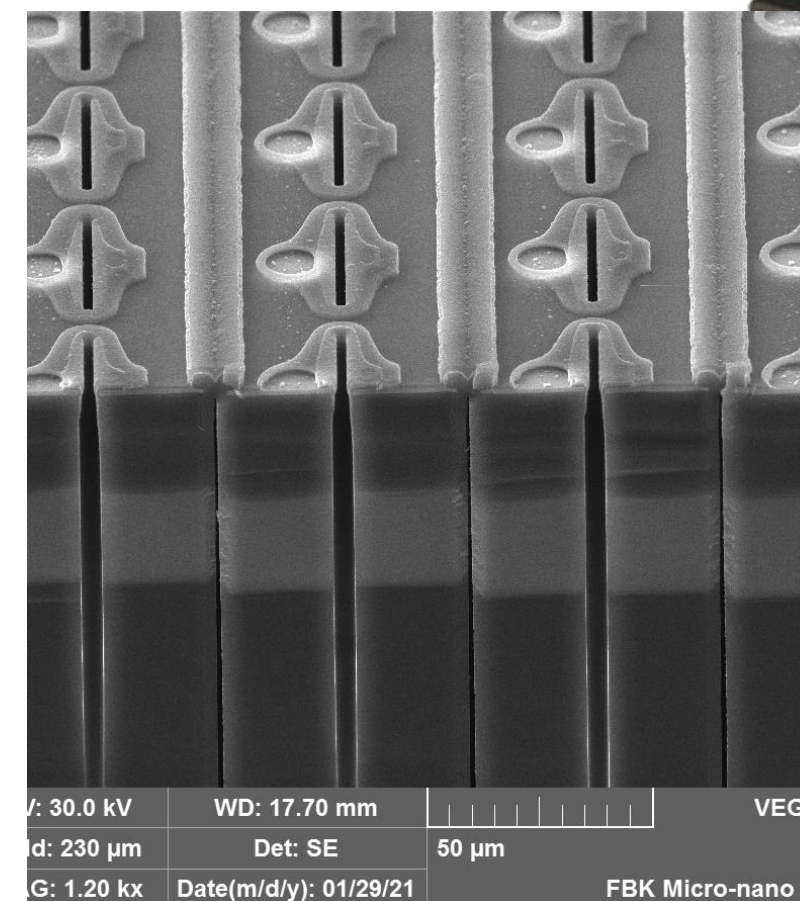
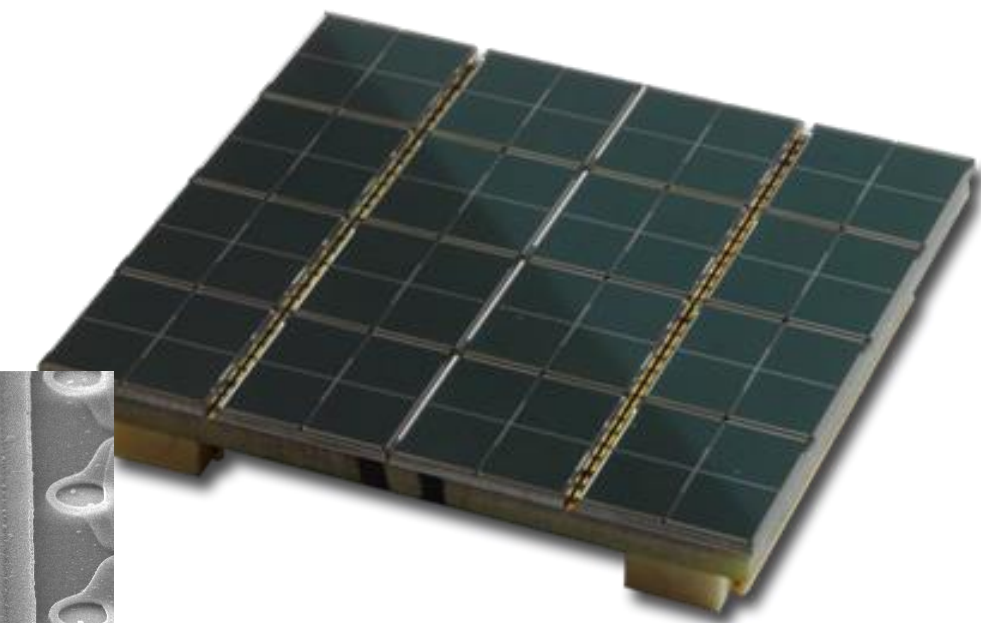
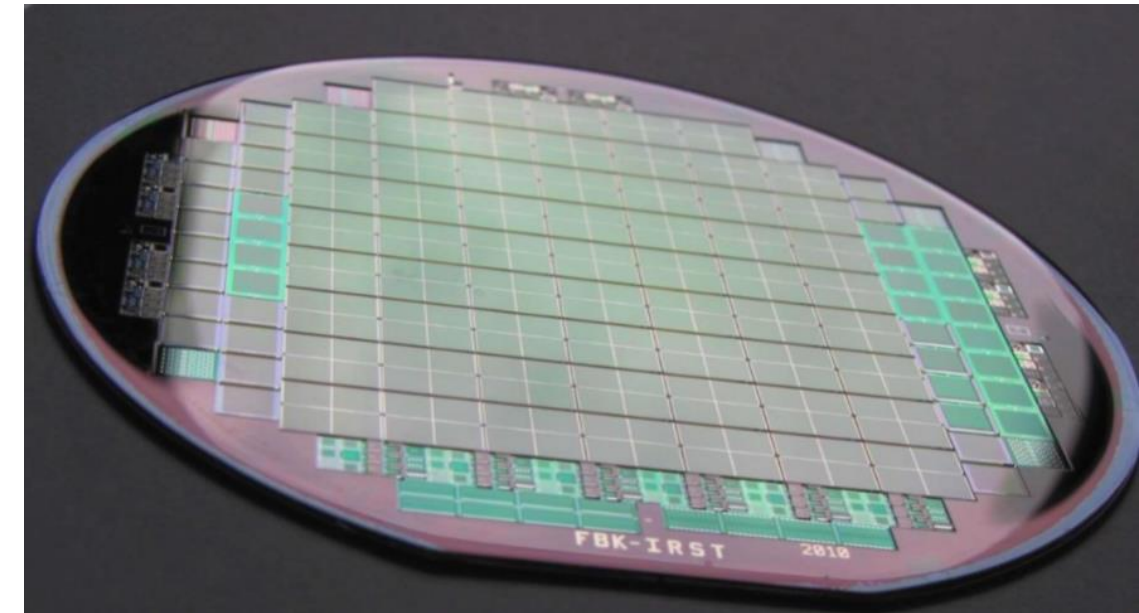
APPLICATION AREAS

Science

- Nuclear and particle physics
- Astronomy
- Space science
- Quantum Science

Industry

- Automotive
- Security and environmental monitoring
- Industrial Quality Control
- Analytical instrumentation
- Applied Quantum Technologies



- Improving the FBK-SiPM technology integrating **Through Silicon Vias (TSV)**
- Exploiting **TSV** to develop innovative segmented SiPMs for hetero-integration with CMOS electronics or photonics components
- Developing a technology for **high-density 3D integration of SPADs and SiPMs with read-out electronics.**
- The **first prototypes** of integrated devices are expected in **2024**.

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OPEN POSITIONS

TITLE	DATE PUBLISHED
A Research position in the field of Game-based Motivational Digital Systems	03/05/2022
FONDAZIONE BRUNO KESSLER (FBK) CALL FOR THE SELECTION OF DIRECTOR FOR RESEARCH, STUDY AND INTERDISCIPLINARY NETWORKING IN THE FOLLOWING AREA: Italian-German Historical Studies	29/04/2022
A research position in the field of Natural Language Processing and Dialogue Systems	27/04/2022
Researcher in energy and climate resilience for sustainable tourism	20/04/2022



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「thank you.」